## Beam Shaping Excellence







Activation and Optimization of Material Properties with Light

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#### **COMPANY** / MARKETS & PRODUCTS / CAPABILITIES / REFERENCES



#### **HISTORY**

#### 1998

LIMOs refractive micro-optics enable materials processing with **direct diode lasers** 



#### 2001

LIMO beam shaping optics enable **high resolution lithography** 

#### 2007

First VIS Activation Line based on LIMOs

beam transformation technology

#### **ACTIVATION LINE**

Enabling new material properties

2012

First UV-L100
Activation Line for the Lift-off process in **OLED production** 

#### 2016

Aquired by **Focuslight** Ltd., China



#### 1999

First LIMO diode laser system

#### 1992

Foundation and start of microoptics production

#### 2004

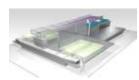
First beam shaping systems
Opening of the Applications & Process
Development Center





#### 2011

Pilot laser system for large-area scalable finishing of surfaces and coatings



#### 2015

First UV-L650 Activation Line for the Lift-off process in **OLED mass production** 

#### 2017

First **UV-L750** for OLED mass production



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**KEY FIGURES** LOCATIONS





350 Employees
30% CAGR
Open package & FC
Industry
Medical
Scientific

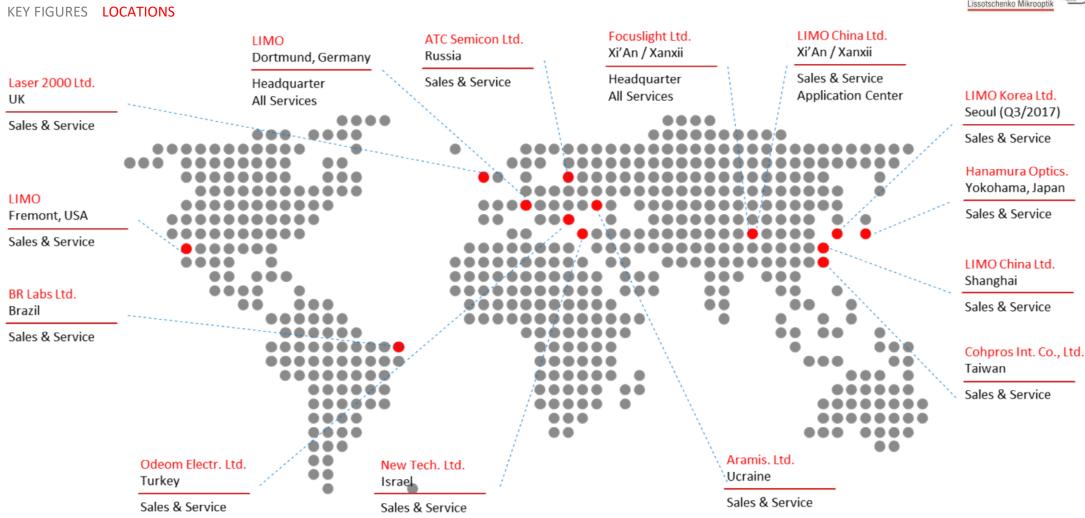




REV'16 18M€
Micro-optics
Laser systems
Optical systems

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**OVERVIEW** MICRO-OPTICS LASER SYSTEMS OPTICAL SYSTEMS





### MICRO-OPTICS

FA / SA collimators

Homogenization

Spot to line or area / to flat top

2D freeform / 3D freeform is comin

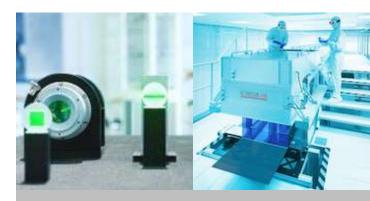


### LASER SYSTEMS

Power levels 10kW...100kW+

Closed loop pyrometer controlled welding

Welding, annealing & dopant activation



### **OPTICAL SYSTEMS**

100...750mm LA, 30μm SA width up to 1200W UV power @120mJ, 10kHz Top hat Gaussian or super Gaussian

Infrared, green, UV

Flat-panel displays, photovoltaics and meta

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### MICRO-OPTICS

Any glass materials / 2D freeform FA / SA collimators
Beam transformation
Homogenization
Spot to line / spot to area
Gauss to top hat
(Micro-) optical assemblies
3D freeform is coming

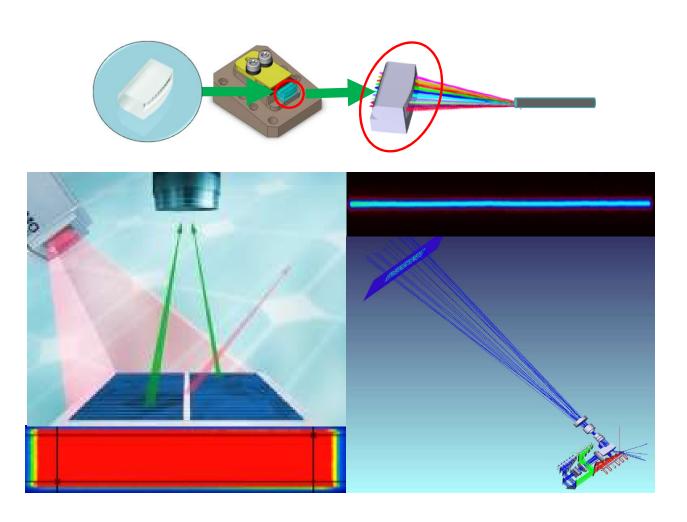
Wafer size up to 300mm x 350mm



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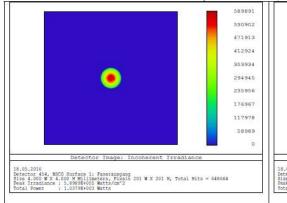


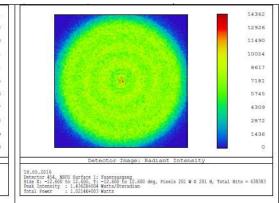
#### **OPTICAL DESIGN TOOLS**

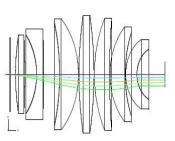
- Zemax
- VirtualLab
- Code V (test), Solstis
- In-house programmed wave optical software

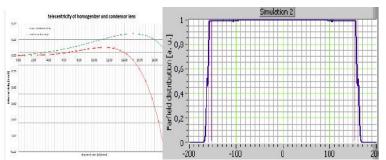
#### **APPLICATIONS**

- Full wavefront performance simulation
- Tolerance analysis
- Contract design studies









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### LASER SYSTEMS

Spot and line systems

0.1...50mn

20...500W

Closed loop pyrometer contro

Process developmen

Annealing

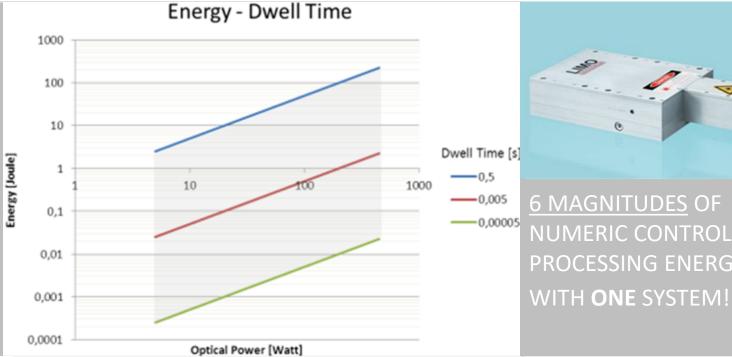
Dopant activation



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### **IR LINES**



6 MAGNITUDES OF NUMERIC CONTROLLED PROCESSING ENERGY

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### **OPTICAL SYSTEMS**

100...750mm line length,  $\lambda$ <800nm (UV/ VIS)

300mm... $\infty$  line length,  $\lambda$ >800nm (IR)

30...600µm beam width

>100KW infrared power

1200W UV power @120mJ, 10kHz

Top hat, Gaussian or super Gaussiar

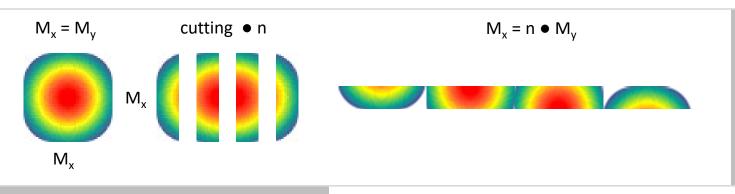
Infrared, green, UV

Flat-panel display lift-off and annealing Photovoltaics Metal



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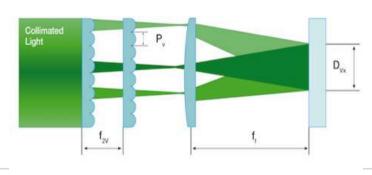


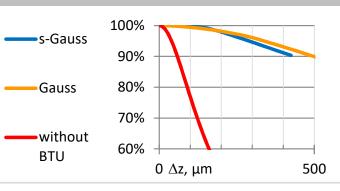
### USE OF LIMO BEAM TRANSFORMER

For generating highly anisotropic beam shapes with unmatched focal depth

# AND MICRO-OPTICAL ARRAYS

For homogenization better than 1%





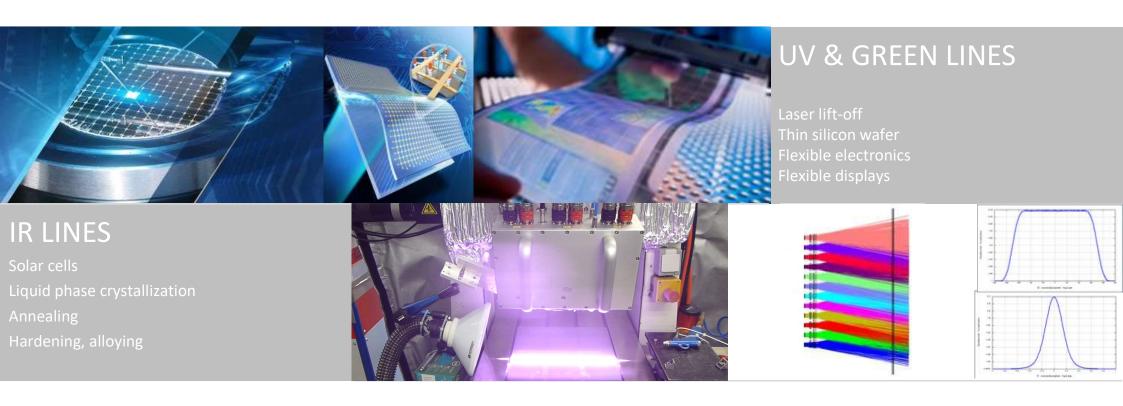
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We look forward to a successful cooperation!